

PATENT ASSIGNMENT COVER SHEET

Electronic Version v1.1
 Stylesheet Version v1.2

EPAS ID: PAT4898453

SUBMISSION TYPE:	NEW ASSIGNMENT	
NATURE OF CONVEYANCE:	ASSIGNMENT	
CONVEYING PARTY DATA		
	Name	Execution Date
	NOBUYUKI ZEN	11/30/2017
	YASUNORI MAWATARI	11/30/2017
	GO FUJII	11/27/2017
	NOBUYUKI YOSHIKAWA	11/23/2017
RECEIVING PARTY DATA		
Name:	NATIONAL INSTITUTE OF ADVANCED INDUSTRIAL SCIENCE AND TECHNOLOGY	
Street Address:	3-1, KASUMIGASEKI 1-CHOME	
City:	CHIYODA-KU, TOKYO	
State/Country:	JAPAN	
Postal Code:	100-8921	
PROPERTY NUMBERS Total: 1		
	Property Type	Number
	Application Number:	15736381
CORRESPONDENCE DATA		
Fax Number:	(860)527-0464	
<i>Correspondence will be sent to the e-mail address first; if that is unsuccessful, it will be sent using a fax number, if provided; if that is unsuccessful, it will be sent via US Mail.</i>		
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Correspondent Name:	MARINA F. CUNNINGHAM, MCCORMICK, PAULDING & HUBER	
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Address Line 2:	7922-0022WOUS	
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ATTORNEY DOCKET NUMBER:	7942-0022WOUS	
NAME OF SUBMITTER:	MARINA F. CUNNINGHAM	
SIGNATURE:	/Marina F. Cunningham/	
DATE SIGNED:	04/04/2018	
Total Attachments: 2		
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ASSIGNMENT

(譲渡証)

As a below named inventor, I hereby declare that:

IN CONSIDERATION of the sum of One Dollar (\$1.00) or the equivalent thereof, and other good and valuable consideration paid to me citizen of Japan by National Institute of Advanced Industrial Science and Technology, a corporation organized under the laws of Japan, located at 3-1, Kasumigaseki 1-chome, Chiyoda-ku, Tokyo 100-8921, Japan, receipt of which is hereby acknowledged I do hereby sell and assign to said National Institute of Advanced Industrial Science and Technology, its successors and assigns, all my right, title and interest, in and for the United States of America, in and to

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invented by me (if only one is named below) or us (if plural inventors are named below) and described in the application for United States Letters Patent therefor, executed on even date herewith, and all United States Letters Patent which may be granted therefor, and all divisions, continuations and extensions thereof, the said interest being the entire ownership of the said Letters Patent when granted,

to be held and enjoyed by said National Institute of Advanced Industrial Science and Technology, its successors, assigns or other legal representatives, to the full end of term for which said Letters Patent may be granted as fully and entirely as the same would have been held and enjoyed by me or us if this assignment and sale had not been made;

And I hereby agree to sign and execute any further documents or instruments which may be necessary, lawful, and proper in the prosecution of the above-named application or in the preparation and prosecution of any continuing, continuation-in-part, substitute, divisional, renewal, reviewed or reissue applications or in any amendment, extension, or interference proceedings, or otherwise to secure the title thereto in said assignee;

And I do hereby authorize and request the Commissioner of Patents to issue said Letters Patent to said National Institute of Advanced Industrial Science and Technology.

Signed on the date(s) indicated aside our signatures:

INVENTOR(S)
(発明者フルネームサイン)

Date Signed
(署名日)

1) 全 伸幸 (Nobuyuki ZEN)

2017年11月30日

2) 馬渡 康徳 (Yasunori MAWATARI)

2017年11月30日

3) 藤井 剛 (Go FUJII)

2017年11月27日

4) (Nobuyuki YOSHIKAWA)

5)

6)

ASSIGNMENT

(譲渡証)

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located at 3-1, Kasumigaseki 1-chome, Chiyoda-ku, Tokyo 100-8921, Japan,

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Science and Technology,

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to be held and enjoyed by said National Institute of Advanced Industrial Science and Technology,

its successors, assigns or other legal representatives, to the full end of term for which said Letters Patent may be granted as fully and entirely as the same would have been held and enjoyed by me or us if this assignment and sale had not been made;

And I hereby agree to sign and execute any further documents or instruments which may be necessary, lawful, and proper in the prosecution of the above-named application or in the preparation and prosecution of any continuing, continuation-in-part, substitute, divisional, renewal, reviewed or reissue applications or in any amendment, extension, or interference proceedings, or otherwise to secure the title thereto in said assignee;

And I do hereby authorize and request the Commissioner of Patents to issue said Letters Patent to said National Institute of Advanced Industrial Science and Technology.

Signed on the date(s) indicated aside our signatures:

INVENTOR(S)

(発明者フルネームサイン)

Date Signed

(署名日)

1) _____ (Nobuyuki ZEN)

2) _____ (Yasunori MAWATARI)

3) _____ (Go FUJII)

4) 吉川 信行 (Nobuyuki YOSHIKAWA)

5) _____

6) _____

23 November 2017
